

PAUL SCHERRER INSTITUT



A. Zandonella :: Vacuum :: Paul Scherrer Institut

Load-lock systems and cathode holder at PSI

EWPA 2019:

European Workshop on Photocathodes for Particle Applications

11. - 13.09.2019, PSI

Cathode Systems Overview

- Cathode
- Cathode preparation system
- In-situ cathode transport
- Cathode load-lock system (Photo injector)

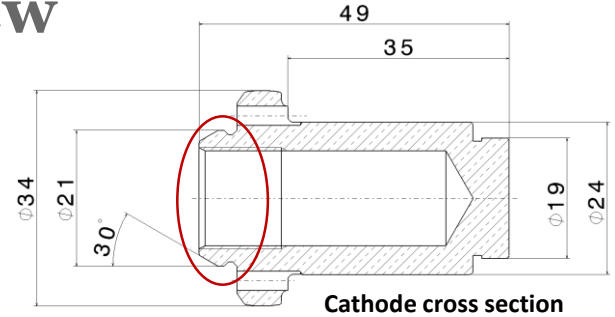
Manipulation of the cathode

- Cathode transfer in between chambers, storage and grabbing
- Cathode pushing mechanism in the cathode load-lock system

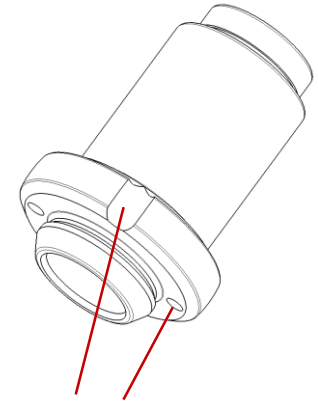
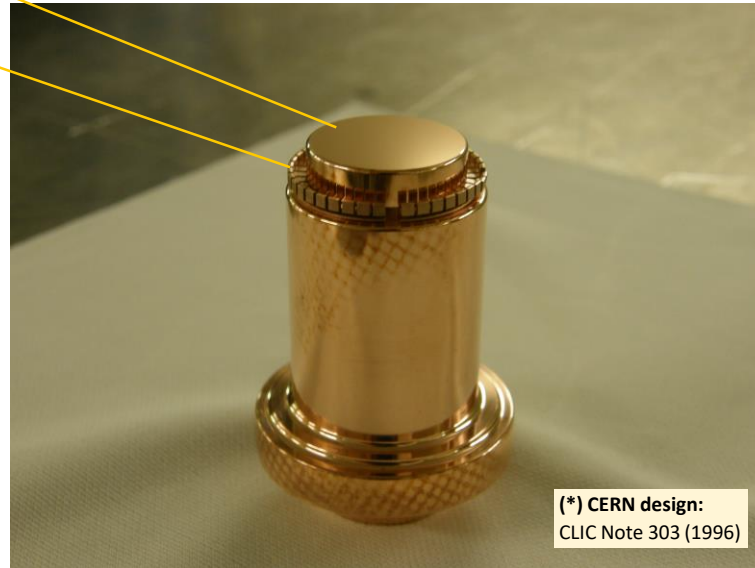
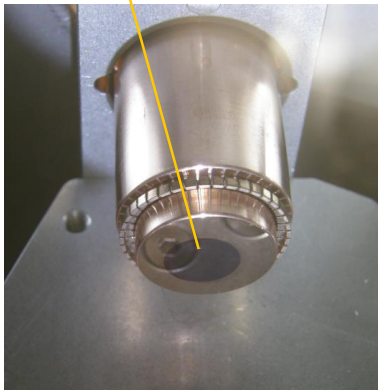
Cathode Systems Overview

Cathode

- Design with challenging interface for cathode grabbing *
- Cathode material: Cu-OFE
- Surface roughness Ra 0.1
- RF-contact spring
Material: CuBe2 (annealed)



Cathode with coating
Cs₂Te layer ($\phi=1\text{cm}$; 40 nm)



**Grooves (2) and bore holes (2)
for cathode grabbing**

Cathode preparation system

Microscope camera

Inspection of Cs₂Te coating through window port mounted on the linking chamber

Cathode annealing and

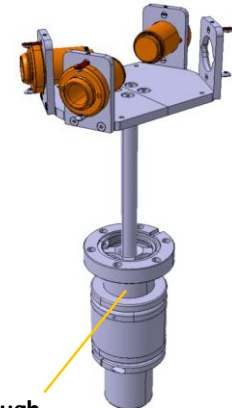
QE measuring chamber ($p < 5 \times 10^{-10}$ mbar)

Linking chamber ($p = 5 \times 10^{-9}$ mbar)

With rotating carousel holding 4 cathodes

- Introduction of new cathodes in the system
- Exchange of the cathodes between chambers
- NexTorr vacuum pump (NEG/SIP)
- Separable vacuum chambers by gate valves

Carousel for storage of 4 cathodes



rotary feedthrough

Vacuum suitcase ($p < 5 \times 10^{-10}$ mbar)

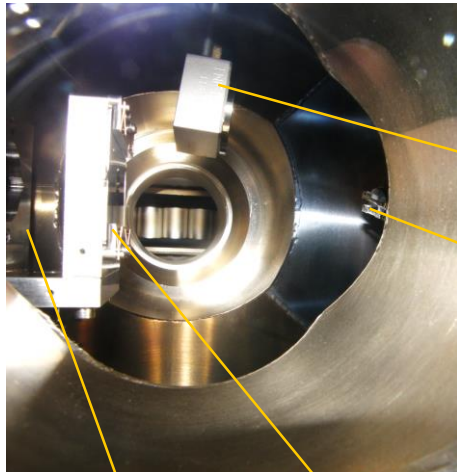
In-situ cathode transport

Quartz micro-balance

Cs source
(SAES getter)

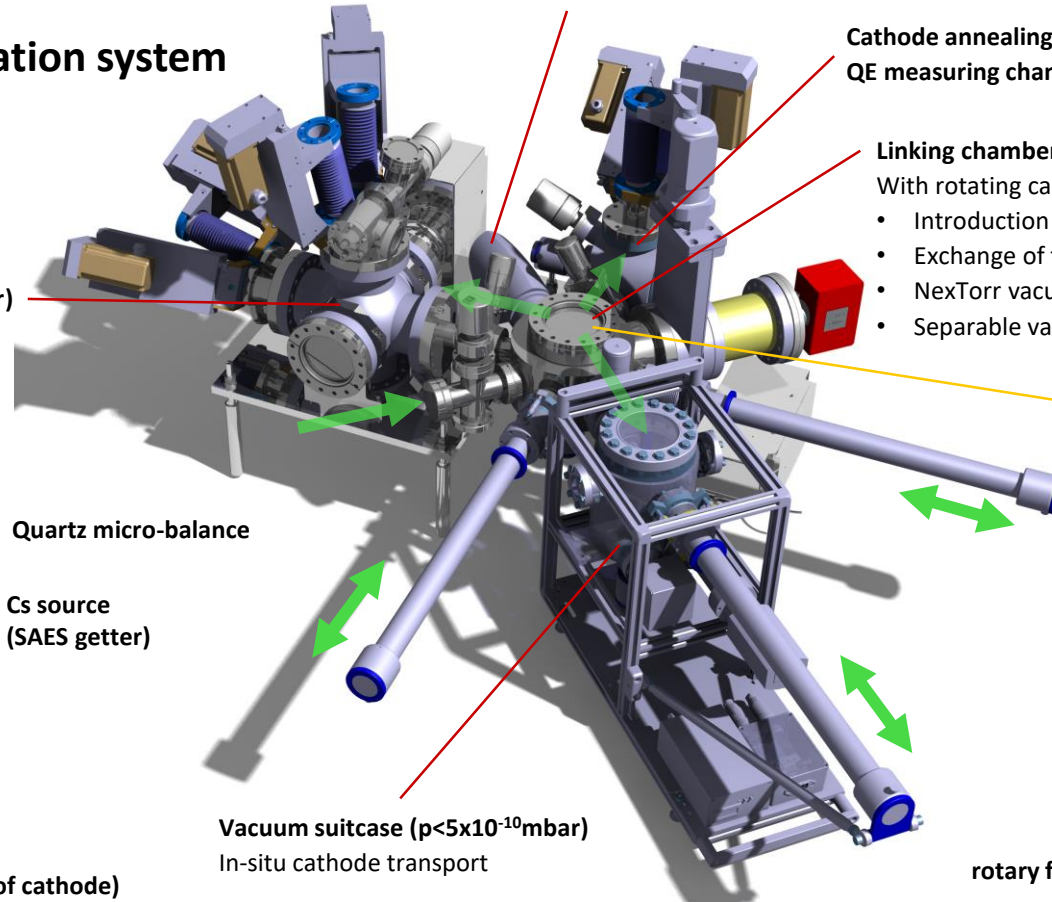
Cs₂Te Evaporation chamber ($p < 5 \times 10^{-10}$ mbar)

- Blind deposition: 15nm Te / 25nm Cs



Cathode holder

Aperture (in front of cathode)



In-situ cathode transport

To avoid contamination of the Cs₂Te cathode surface at atmosphere the cathodes are transported in a so called “**vacuum suitcase**” from the preparation system to the photo injector

- Designed by Ferrovac GmbH
- Pressure 5×10^{-10}mbar
- Weight: 10kg

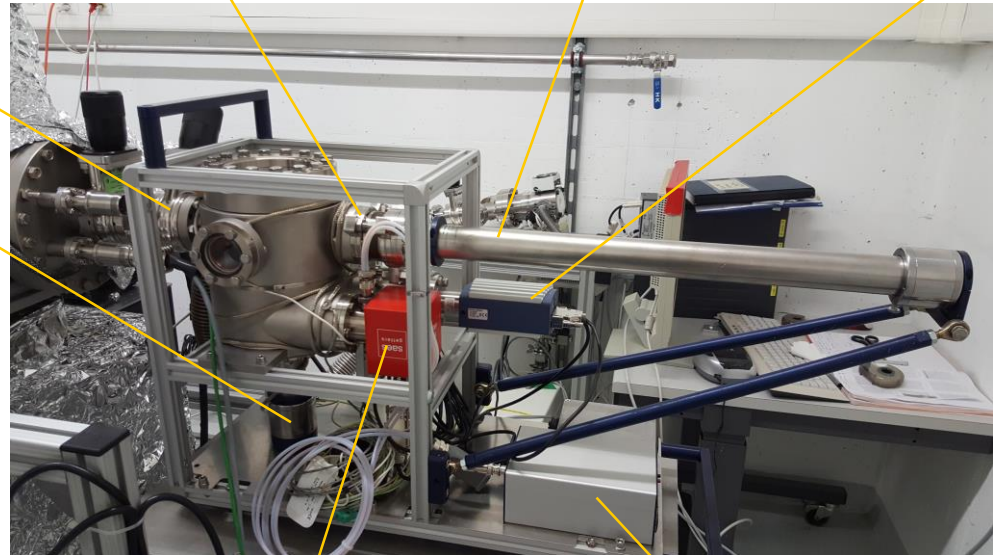
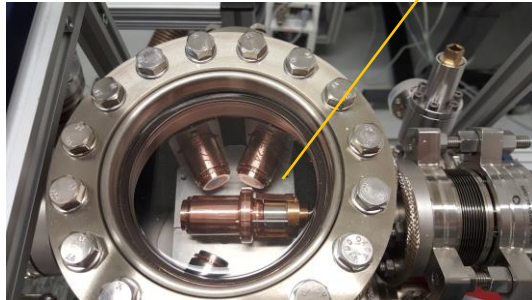
Port aligner for adjustment of the linear rotary feedthrough orientation

Linear rotary feedthrough for transfer motion of the cathodes

Pressure measurement with display

Gate valve (manual)

Carousel mounted on a rotary feedthrough, holding 4 cathodes



NexTorr vacuum pump (NEG/SIP)

Portable HV power supply

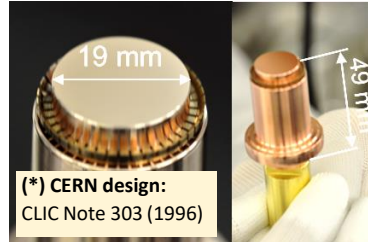
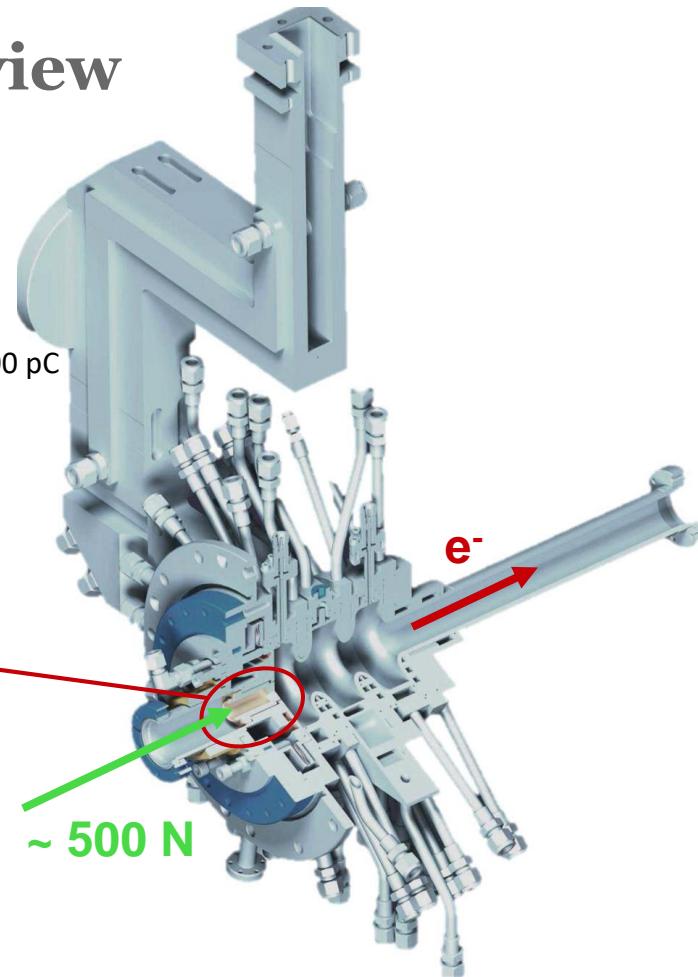
Cathode Systems Overview

Cathode load-lock system (Photo injector)

To reach a stable resonant frequency in the gun the RF-contact spring on the cathode has to be pushed with a force of ~500N into the cathode plug reception of the photo injector (gun).

SwissFEL RF Photo injector:

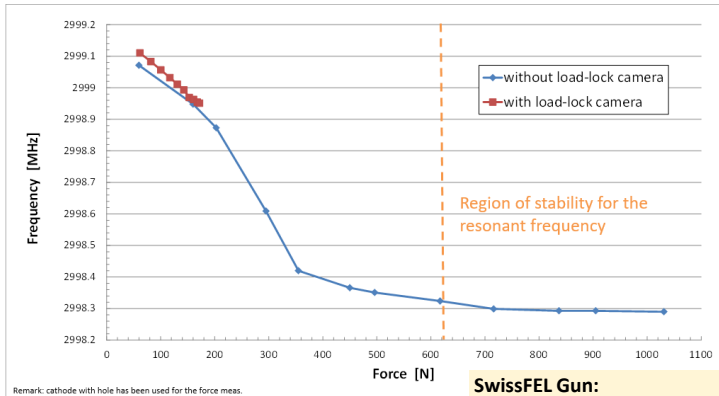
- S band, 2.5 Cell; 7 MeV;
- 100 MV/m; 100 Hz; 10 - 200 pC



Exchangeable cathode plug *

Example of a force vs. frequency measurement at PSI:

Positioning of the cathode (2): measurement of the force



SwissFEL Gun:

low-power measurements in WLHA 9/5/14

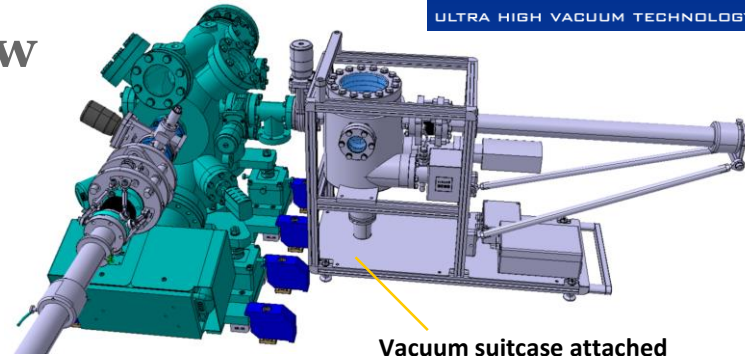
A.Citterio, M.Bopp, L.Stingelin, D.Bieri, N.Gaiffi

Cathode Systems Overview

Cathode load-lock system (Photo injector)

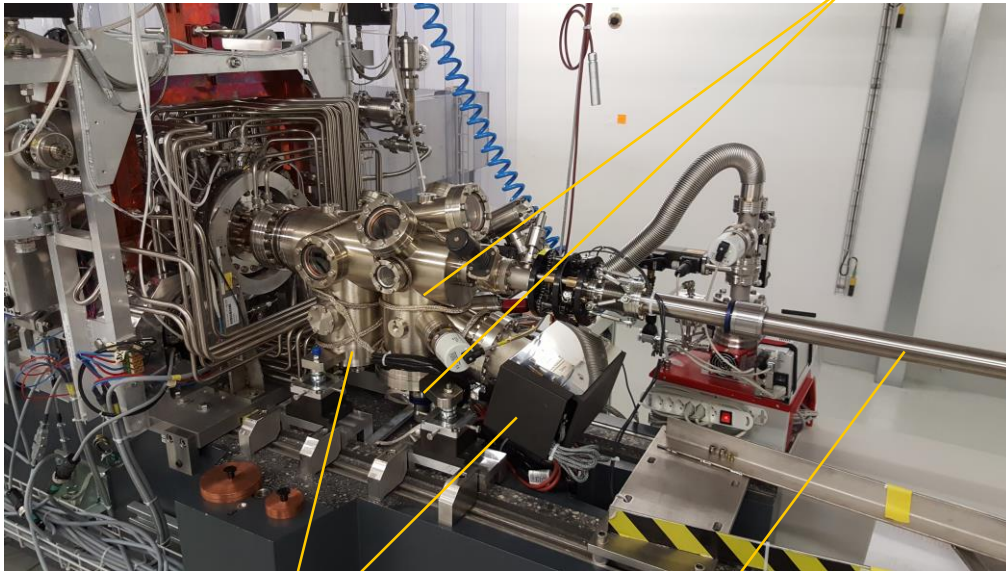
Through a short load lock with discreet pumping the cathodes can be transferred in-situ from the vacuum suitcase to the load lock chamber.

- Designed by Ferrovac GmbH
- Pressure <math> < 5 \times 10^{-11} \text{ mbar}</math>



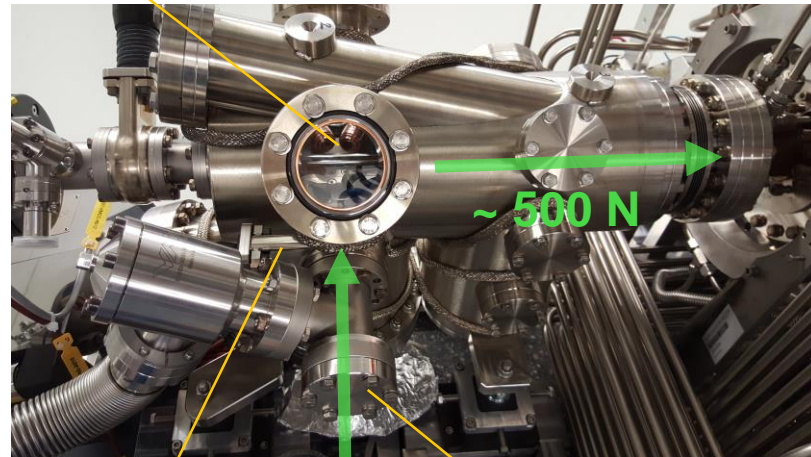
Rotary feedthrough with carousel holding 4 cathodes

Vacuum suitcase attached to the load-lock chamber



vacuum pumps (NEG/SIP)

Linear rotary feedthrough



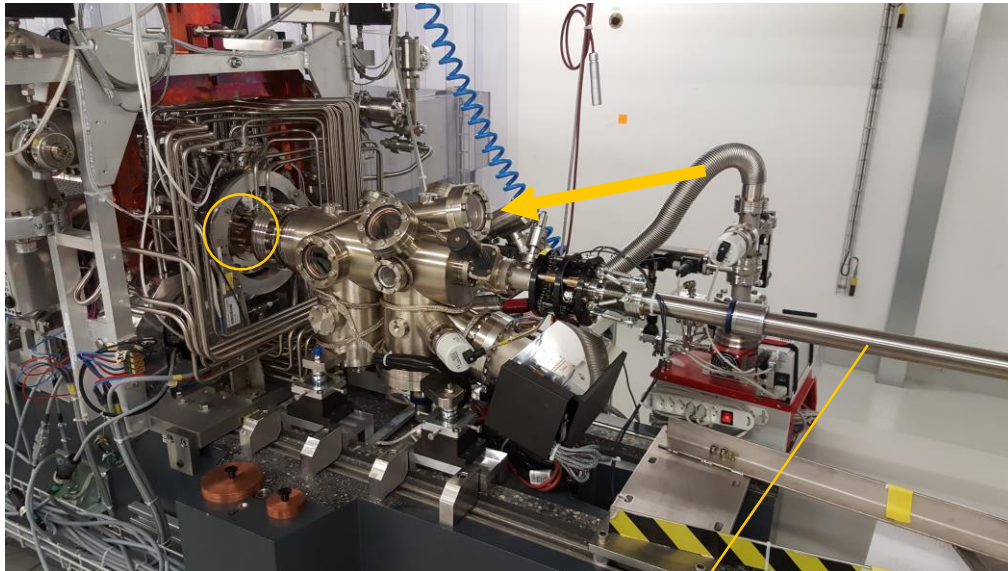
Gate valve (manual)

DN40CF flange for attachment of the vacuum suitcase

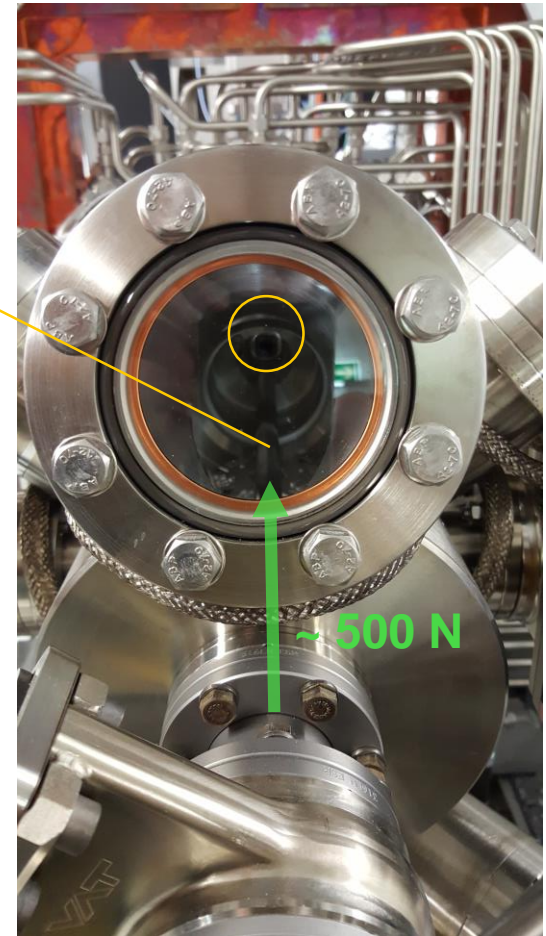


Cathode load-lock system (Photo injector)

The linear rotary feedthrough grabs a cathode from the carousel. Shaft, grabber and cathode are then pushed into the cathode plug reception of the photo injector

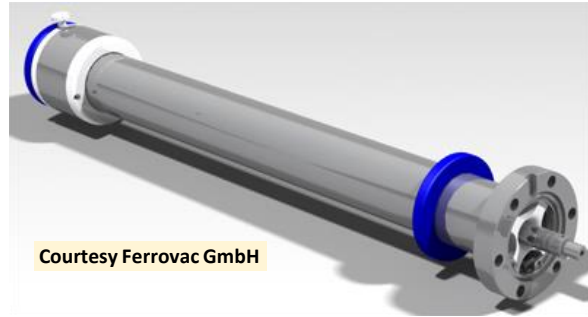


Linear rotary feedthrough



Cathode transfer in between chambers, storage and grabbing

The transfer of the cathodes in between the UHV chambers is done with magnetically driven linear rotary feedthroughs.



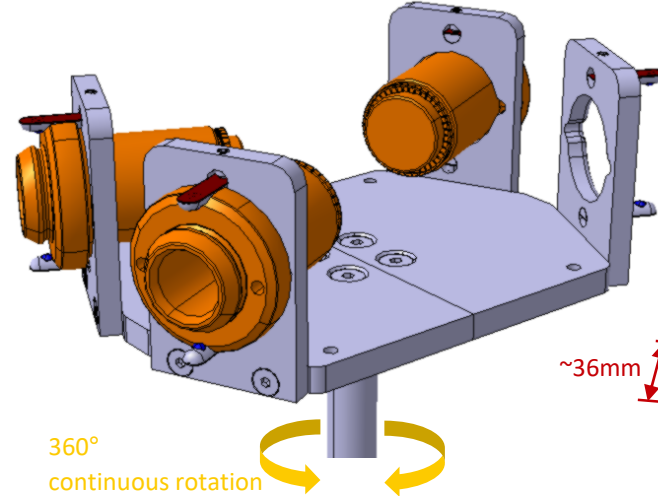
Courtesy Ferrovac GmbH

Each feedthrough is equipped with a port-aligner to adjust the transfer level



Courtesy Ferrovac GmbH

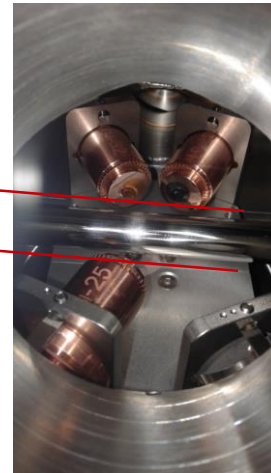
The cathodes are stored on stainless steel plates with a bore hole, mounted vertically on a base plate. The two grooves on the outside diameter of the cathodes collar are used to hold them in position.



360°
continuous rotation

Carousel with storage for 4 cathodes,
mounted on magnetically driven
rotary feedthrough

Clearance for
cathode transfer



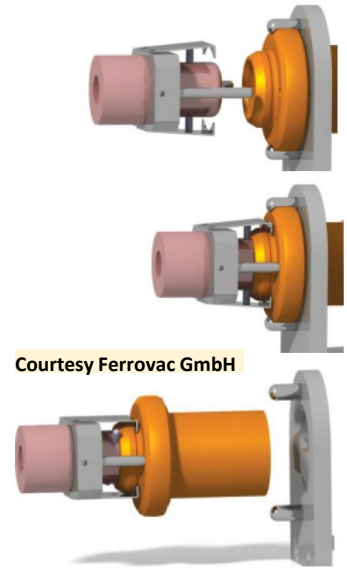
~36mm

Manipulation of the cathode

Cathode transfer in between chambers, storage and grabbing

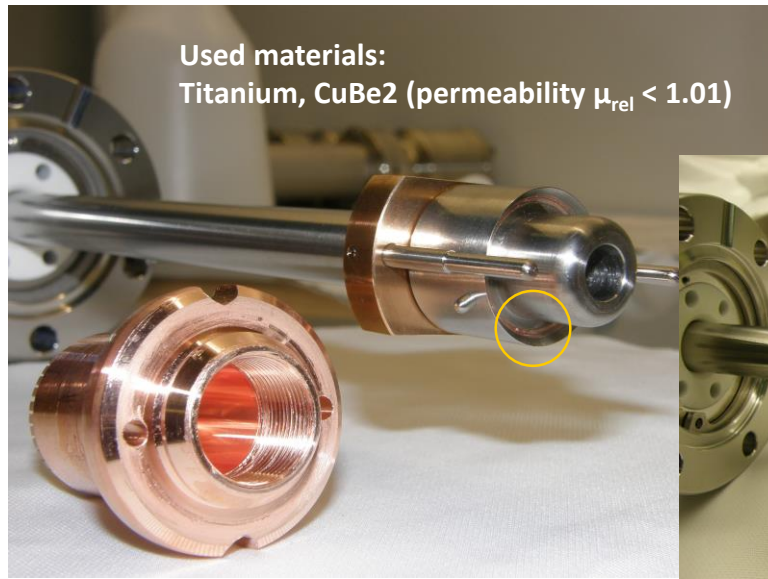
Issues with the 1st grabber type

- The cathode get stuck in the grabber due to vacuum erosion
- The cathode was not in line with the manipulator shaft ("hang down")

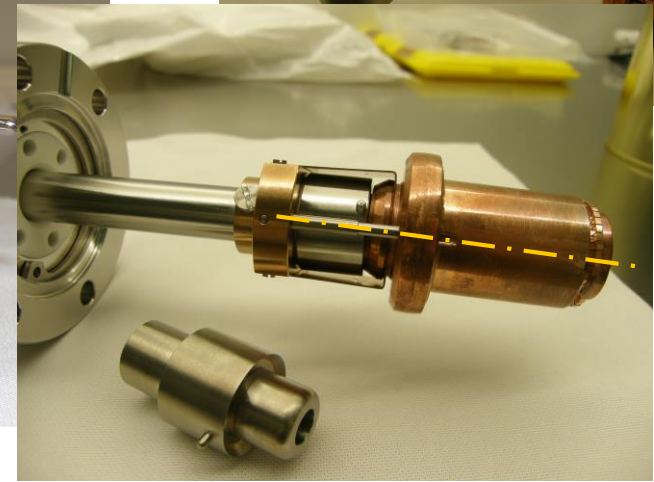


Courtesy Ferrovac GmbH

Concept of the cathode grabbing mechanism



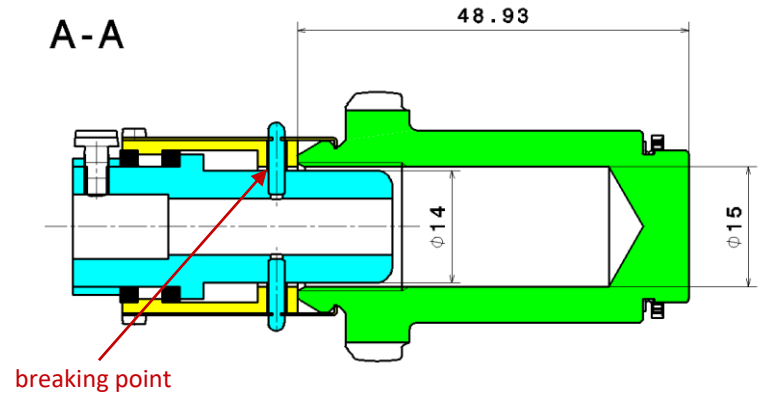
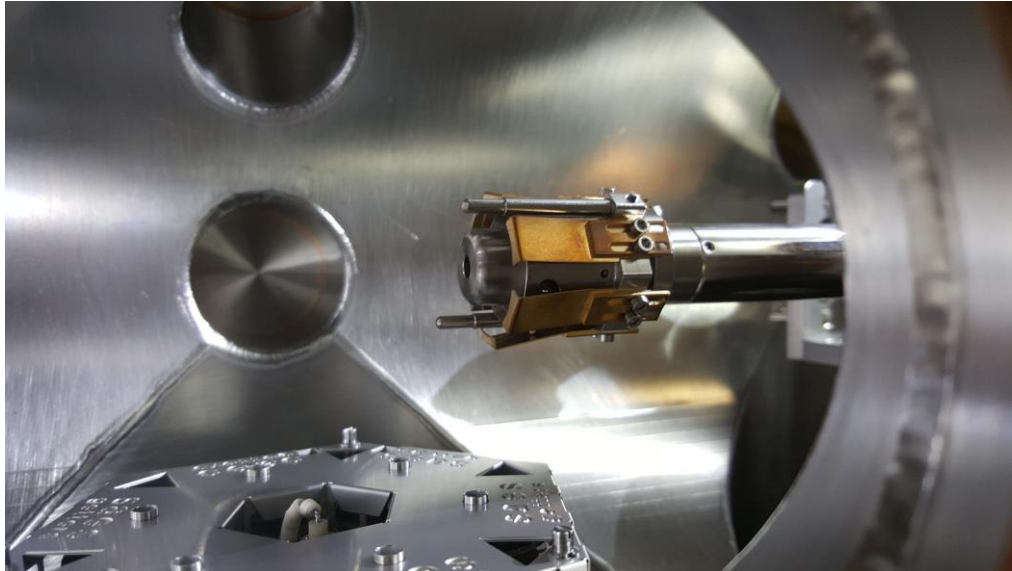
Used materials:
Titanium, CuBe2 (permeability $\mu_{rel} < 1.01$)



Cathode transfer in between chambers, storage and grabbing

1st improvements of the cathode grabbing mechanism

- New concept without friction between cathode and grabber
- 6 adjustable leaf springs to avoid “hang down” of the cathode



Result with the 2nd grabber type

- The cathode didn't get stuck anymore
- The problem with the “hang down” was improved

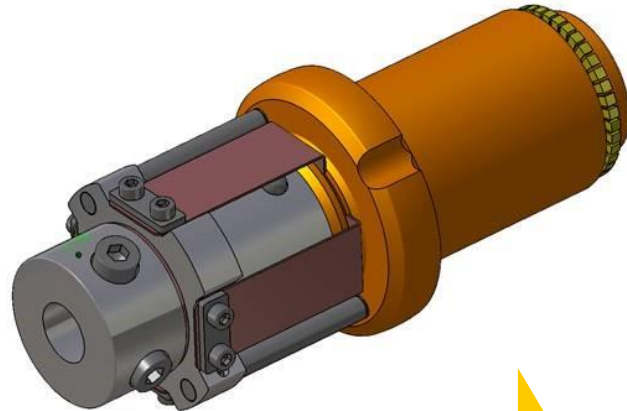
Issues with the 2nd grabber type

- The opening pins were too thin and broke
- The leaf springs started to fatigue after a while

Cathode transfer in between chambers, storage and grabbing

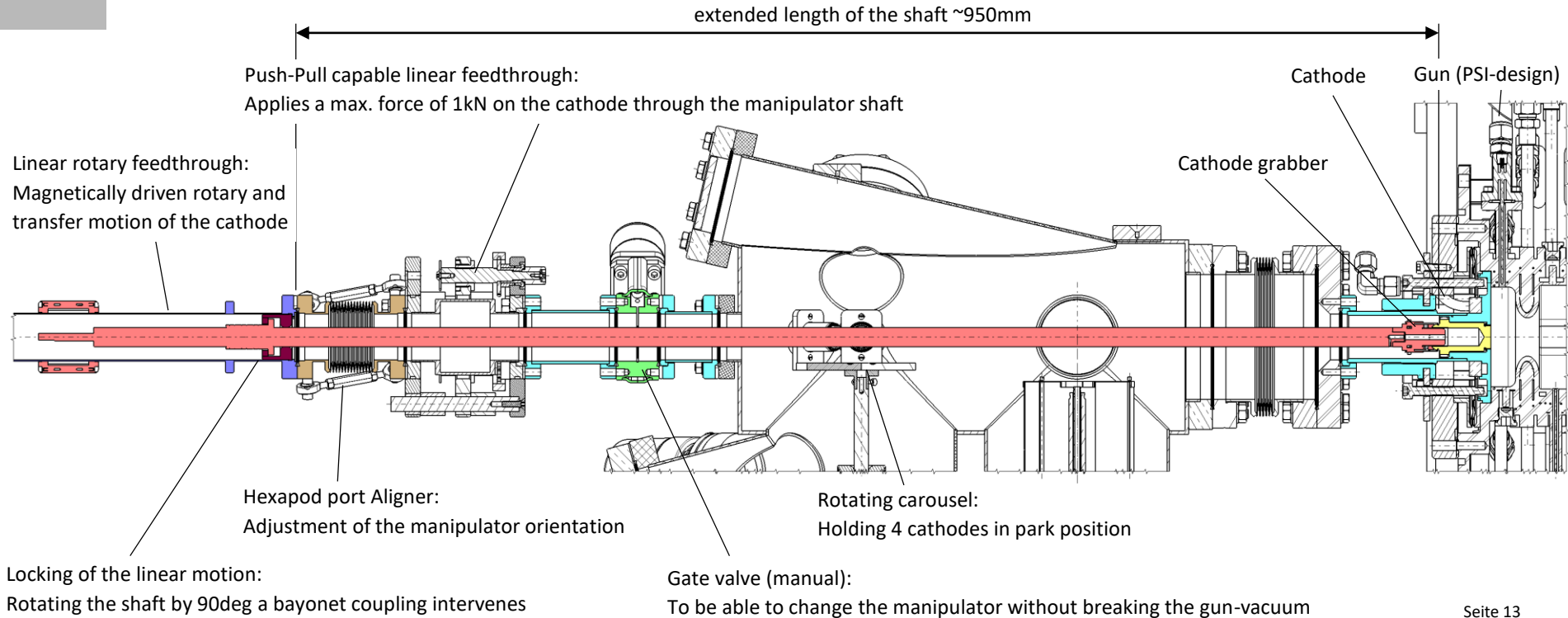
3rd improvements of the grabber

- Thicker opening pins
- Thicker leaf springs (but reduced amount of springs for a reasonable opening torque)
- Spring material: CuBe2 (annealed)



This last version of the grabber is currently built-in the cathode preparation system for test purpose

Cathode pushing mechanism in the load-lock system



Push-Pull capable linear feedthrough with force measurement

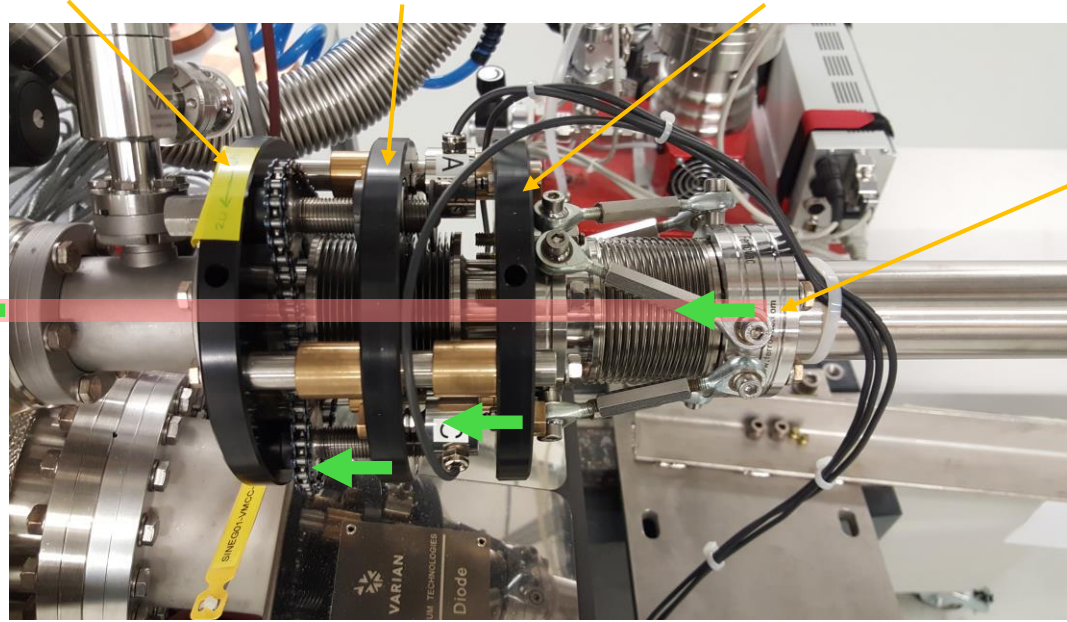
fixed base plate
connected to CF40 flange of the bellows
and the load lock chamber

moveable intermediate plate
actuated by 3 threaded spindles
mounted on the base plate

moveable pulling and pushing plate
connected to the intermediate plate with 3 force transducers
and the 2nd flange of the bellows



~ 500 N




bayonet coupling inside the manipulator
to guarantee force closure from the linear
feedthrough to the manipulator shaft

Ideas for improvements on the load-lock system

Issues:

- The pushing force measurement is not accurate enough due to...
 - the own weight of the manipulator
 - The elasticity of the long manipulator shaft
 - Deformation of the photo injector, which is slightly deformed when applying force

For a future design of the load-lock the concept must consider...

- 
- The shortest possible manipulator shaft length
 - A force measurement in the direct line of force
 - A force closure with the photo injector, to avoid any deformation when pushing (decoupling must still be guaranteed)

Many thanks to:

- Romain Ganter
- SLS vacuum team
- Ferrovac GmbH

